

Lecture 15

OUTLINE

- MOSFET structure & operation (qualitative)
- Review of electrostatics
- The (N)MOS capacitor
 - Electrostatics
 - Charge vs. voltage characteristic
- Reading: Chapter 6.1-6.2.1

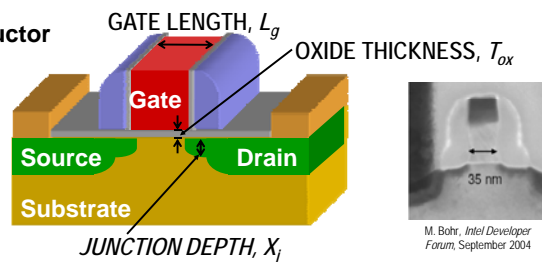
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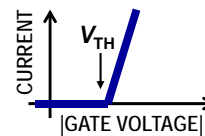
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The MOSFET

Metal-Oxide-Semiconductor
Field-Effect Transistor:



- Current flowing through the **channel** between the **source** and **drain** is controlled by the **gate voltage**.
- “N-channel” & “P-channel” MOSFETs operate in a complementary manner
“CMOS” = Complementary MOS

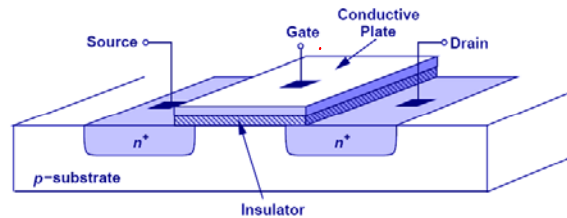


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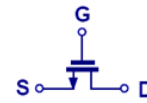
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N-Channel MOSFET Structure



Circuit symbol



- The conventional gate material is heavily doped polycrystalline silicon (referred to as “polysilicon” or “poly-Si” or “poly”)
 - Note that the gate is usually doped the same type as the source/drain, *i.e.* the gate and the substrate are of opposite types.
- The conventional gate insulator material is SiO₂.
- To minimize current flow between the substrate (or “body”) and the source/drain regions, the p-type substrate is grounded.

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Review: Charge in a Semiconductor

- Negative charges:
 - Conduction electrons (density = n)
 - Ionized acceptor atoms (density = N_A)
- Positive charges:
 - Holes (density = p)
 - Ionized donor atoms (density = N_D)
- The **net charge density** [C/cm³] in a semiconductor is

$$\rho = q(p - n + N_D - N_A)$$

- Note that p , n , N_D , and N_A each can vary with position.
- The mobile carrier concentrations (n and p) in the channel of a MOSFET can be modulated by an electric field via V_G .

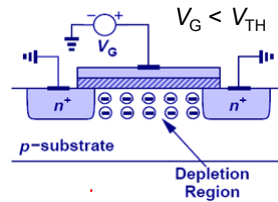
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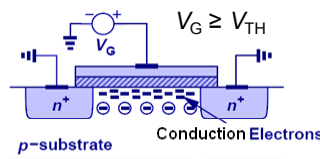
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Channel Formation (Qualitative)

- As the gate voltage (V_G) is increased, holes are repelled away from the substrate surface.
 - The surface is depleted of mobile carriers. The charge density within the **depletion region** is determined by the dopant ion density.



- As V_G increases above the **threshold voltage** V_{TH} , a layer of conduction electrons forms at the substrate surface.
 - For $V_G > V_{TH}$, $n > N_A$ at the surface.
 - The surface region is “inverted” to be n-type.



The electron **inversion layer** serves as a resistive path (**channel**) for current to flow between the heavily doped (*i.e.* highly conductive) **source** and **drain** regions.

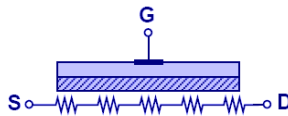
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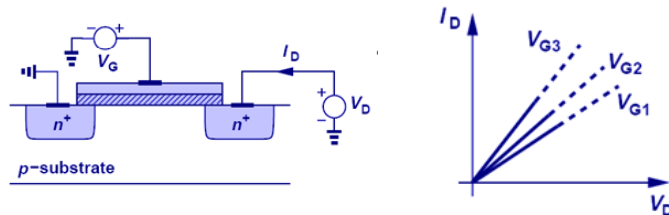
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Voltage-Dependent Resistor

- In the ON state, the MOSFET channel can be viewed as a resistor.



- Since the mobile charge density within the channel depends on the gate voltage, the channel resistance is voltage-dependent.



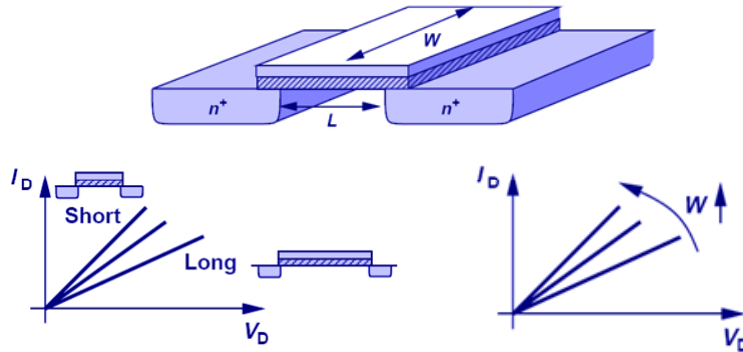
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Channel Length & Width Dependence

- Shorter channel length and wider channel width each yield lower channel resistance, hence larger drain current.
 - Increasing W also increases the gate capacitance, however, which limits circuit operating speed (frequency).



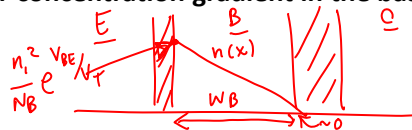
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Comparison: BJT vs. MOSFET

- In a BJT, current (I_C) is limited by diffusion of carriers from the emitter to the collector.
 - I_C increases exponentially with input voltage (V_{BE}), because the **carrier concentration gradient in the base** is proportional to e^{V_{BE}/V_T}



- In a MOSFET, current (I_D) is limited by drift of carriers from the source to the drain.
 - I_D increases \sim linearly with input voltage (V_G), because the **carrier concentration in the channel** is proportional to $(V_G - V_{TH})$

In order to understand how MOSFET design parameters affect MOSFET performance, we first need to understand how a MOS capacitor works...

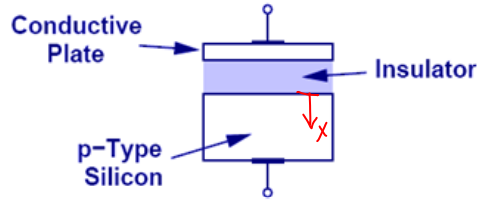
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MOS Capacitor

- A metal-oxide-semiconductor structure can be considered as a parallel-plate capacitor, with the top plate being the positive plate, the gate insulator being the dielectric, and the p-type semiconductor substrate being the negative plate.



- The negative charges in the semiconductor (for $V_G > 0$) are comprised of conduction electrons and/or acceptor ions.

In order to understand how the potential and charge distributions within the Si depend on V_G , we need to be familiar with electrostatics...

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Gauss' Law

$$\nabla \cdot \mathbf{E} = \frac{\rho}{\epsilon}$$

ρ is the net charge density
 ϵ is the dielectric permittivity

→ If the magnitude of electric field changes, there must be charge!

- In a charge-free region, the electric field must be constant.**
- Gauss' Law equivalently says that if there is a *net* electric field leaving a region, there must be positive charge in that region:

$$\oint_V \nabla \cdot \mathbf{E} dV = \oint_S \mathbf{E} \cdot d\mathbf{S}$$

$$\oint_V \nabla \cdot \mathbf{E} dV = \oint_V \frac{\rho}{\epsilon} dV$$

$$\oint_V \frac{\rho}{\epsilon} dV = \frac{Q}{\epsilon}$$

$$\oint \mathbf{E} \cdot d\mathbf{S} = \frac{Q}{\epsilon}$$

The integral of the electric field over a closed surface is proportional to the charge within the enclosed volume

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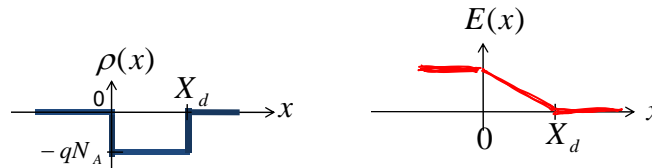
Gauss' Law in 1-D

$$\nabla \cdot \mathbf{E} = \frac{dE}{dx} = \frac{\rho}{\epsilon}$$

$$dE = \frac{\rho}{\epsilon} dx$$

$$E(x) = E(x_0) + \int_{x_0}^x \frac{\rho(x')}{\epsilon} dx'$$

- Consider a pulse charge distribution:



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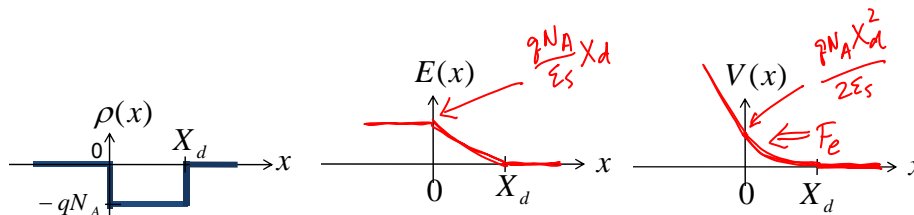
Electrostatic Potential

- The electric field (force) is related to the potential (energy):

$$E = -\frac{dV}{dx} \Rightarrow \frac{d^2V(x)}{dx^2} = -\frac{\rho(x)}{\epsilon}$$

- Note that an electron ($-q$ charge) drifts in the direction of increasing potential:

$$F_e = -qE = -q \frac{dV}{dx}$$



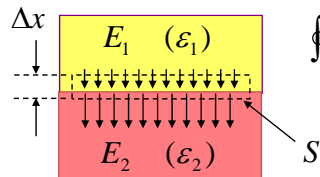
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Boundary Conditions

- **Electrostatic potential must be a continuous function.** Otherwise, the electric field (force) would be infinite.
- Electric field does not have to be continuous, however. Consider an interface between two materials:



$$\oint \epsilon E \cdot dS = -\epsilon_1 E_1 S + \epsilon_2 E_2 S = Q_{inside}$$

If $Q_{inside} \xrightarrow{\Delta x \rightarrow 0} 0$, then

$$-\epsilon_1 E_1 S + \epsilon_2 E_2 S = 0$$

$$\frac{E_1}{E_2} = \frac{\epsilon_2}{\epsilon_1}$$

Discontinuity in electric displacement $\epsilon E \rightarrow$ charge density at interface!

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MOS Capacitor Electrostatics

- **Gate electrode:**
 - Since $E(x) = 0$ in a metallic material, **$V(x)$ is constant.**
- **Gate-electrode/gate-insulator interface:**
 - The gate charge is located at this interface.
 - $E(x)$ changes to a non-zero value inside the gate insulator.
- **Gate insulator:**
 - Ideally, there are no charges within the gate insulator.
 - $E(x)$ is constant, and **$V(x)$ is linear.**
- **Gate-insulator/semiconductor interface:**
 - Since the dielectric permittivity of SiO_2 is lower than that of Si, $E(x)$ is larger in the gate insulator than in the Si.
- **Semiconductor:**
 - If $\rho(x)$ is constant (non-zero), then **$V(x)$ is quadratic.**

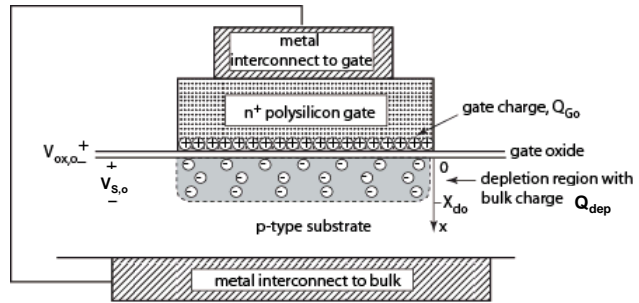
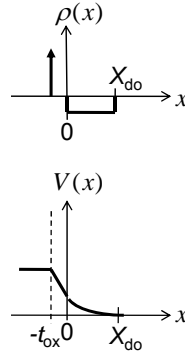
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MOS Capacitor: $V_{GB} = 0$

- If the gate and substrate materials are not the same (typically the case), there is a built-in potential ($\sim 1V$ across the gate insulator).
 - Positive charge is located at the gate interface, and negative charge in the Si.
 - The substrate surface region is depleted of holes, down to a depth X_{do}



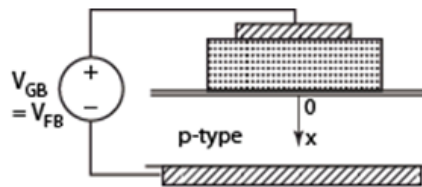
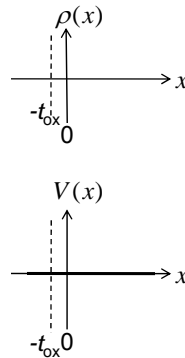
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Flatband Voltage, V_{FB}

- The built-in potential can be “cancelled out” by applying a gate voltage that is equal in magnitude (but of the opposite polarity) as the built-in potential. This gate voltage is called the **flatband voltage** because the resulting potential profile is flat.



There is no net charge (*i.e.* $\rho(x)=0$) in the semiconductor under for $V_{GB} = V_{FB}$.

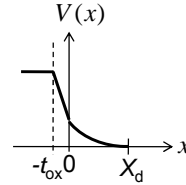
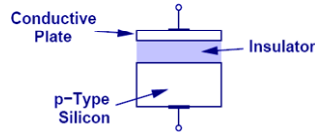
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Voltage Drops across a MOS Capacitor

$$V_{GB} - V_{FB} = V_{ox} + V_S$$



- If we know the total charge within the semiconductor (Q'_S), we can find the electric field within the gate insulator (E_{ox}) and hence the voltage drop across the gate insulator (V_{ox}):

$$\oint E \cdot dS = E_{ox} A = \frac{-Q'_S}{\epsilon_{ox}} \quad V_{ox} = E_{ox} t_{ox} = \left(\frac{-Q'_S}{A \epsilon_{ox}} \right) t_{ox} = \frac{-Q_S}{C_{ox}}$$

where Q_S is the areal charge density in the semiconductor [C/cm^2]

and $C_{ox} \equiv \epsilon_{ox}/t_{ox}$ is the areal gate capacitance [F/cm^2]

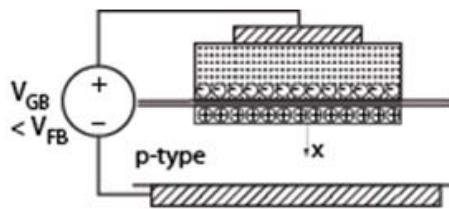
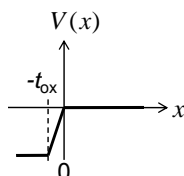
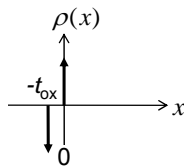
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$V_{GB} < V_{FB}$ (Accumulation)

- If a gate voltage more negative than V_{FB} is applied, then holes will accumulate at the gate-insulator/semiconductor interface.



Areal gate charge density [C/cm^2]:

$$Q_G = C_{ox} \cdot (V_{GB} - V_{FB})$$

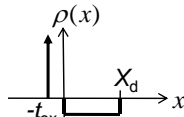
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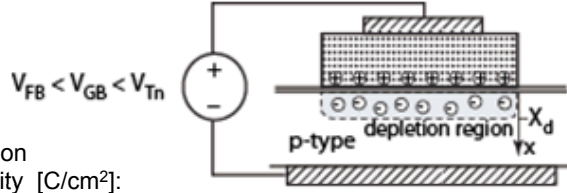
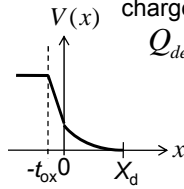
$V_{FB} < V_{GB} < V_{TH}$ (Depletion)

- If the applied gate voltage is greater than V_{FB} , then the semiconductor surface will be depleted of holes.
 - If the applied gate voltage is less than V_{TH} , the concentration of conduction electrons at the surface is smaller than $N_A \rightarrow \rho(x) \cong -qN_A(x)$



Areal depletion charge density [C/cm²]:

$$Q_{dep} = -qN_A X_d$$



$$V_{GB} - V_{FB} = V_{ox} + V_B = \frac{qN_A X_d}{C_{ox}} + \frac{qN_A X_d^2}{2\epsilon_{Si}}$$

$$\Rightarrow X_d = \frac{\epsilon_{Si}}{C_{ox}} \left[\sqrt{1 + \frac{2C_{ox}^2 (V_{GB} - V_{FB})}{q\epsilon_{Si} N_A}} - 1 \right]$$

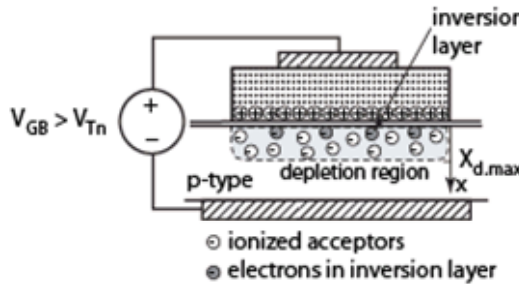
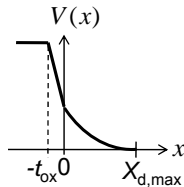
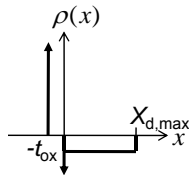
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$V_{GB} > V_{TH}$ (Inversion)

- If the applied gate voltage is greater than V_{TH} , then $n > N_A$ at the semiconductor surface.
 - At $V_{GB} = V_{TH}$, the total potential dropped in the Si is $2\phi_B$ where $\phi_B = V_T \ln\left(\frac{N_A}{n_i}\right)$



$$V_{TH} = V_{FB} + 2\phi_B + \frac{\sqrt{2q\epsilon_{Si} N_A (2\phi_B)}}{C_{ox}}$$

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Maximum Depletion Depth, $X_{d,max}$

- As V_{GB} is increased above V_{TH} , V_S and hence the depth of the depletion region (X_d) increases very slowly.
 - This is because n increases exponentially with V_S , whereas X_d increases with the square root of V_S . Thus, most of the incremental negative charge in the semiconductor comes from additional conduction electrons rather than additional ionized acceptor atoms, when n exceeds N_A .
- X_d can be reasonably approximated to reach a maximum value ($X_{d,max}$) for $V_{GB} \geq V_{TH}$.
 - Q_{dep} thus reaches a maximum of $Q_{dep,max}$ at $V_{GB} = V_{TH}$.
- If we assume that only the inversion-layer charge increases with increasing V_{GB} above V_{TH} , then

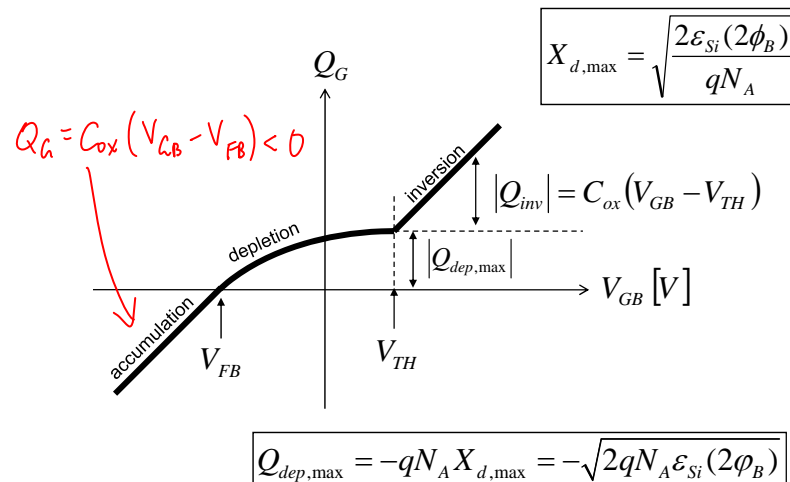
$$Q_{inv} = -C_{ox}(V_{GB} - V_{TH}) \text{ and so } Q_G(V_{GB}) = C_{ox}(V_{GB} - V_{TH}) + Q_{dep,max}$$

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Q-V Curve for MOS Capacitor



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